

IN THE U.S. PATENT AND TRADEMARK OFFICE  
I N F O R M A T I O N   S H E E T

Applicant:           HYVARINEN, Jaakko  
                      STENMAN, Folke

Application No.:

Filed:                April 27, 2001

For:                 METHOD AND DEVICE FOR MODIFYING THE IRRADIANCE DISTRIBUTION  
                      OF A RADIATION SOURCE

Priority Claimed Under 35 U.S.C. 119 and/or 120:

COUNTRY	DATE	NUMBER
Finland	04/28/00	20001010

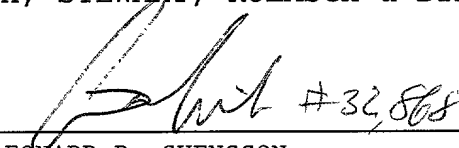
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                              Falls Church, Virginia 22040-0747  
                              (703) 205-8000

The above information is submitted to advise the USPTO of all relevant facts in connection with the present application. A timely executed Declaration in accordance with 37 CFR 1.64 will follow.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By

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